**INFORMATION DISCLOSURE CITATION**  
(Use several sheets if necessary)

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Docket Number (Optional)

YPL-0080

Application Number

10/773,507

Applicant(s)

Taejoon KWON

Filing Date

2/5/2004

Group Art Unit

1645

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		<del>6,188,783</del>	<del>2/13/2001</del>	<del>Balaban et al.</del>	<del>382</del>	<del>129</del>	<del>7/24/1998</del>
		<del>6,403,314, B1</del>	<del>6/11/2002</del>	<del>Lange et al.</del>	<del>435</del>	<del>6</del>	<del>2/4/2000</del>
		<del>6,251,588 B1</del>	<del>6/26/2001</del>	<del>Shannon et al.</del>	<del>435</del>	<del>6</del>	<del>2/10/1998</del>

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		<del>WO 01/94611 A2</del>	<del>12/13/2001</del>	<del>PCT</del>				
		<del>1,103,910</del>	<del>5/30/2001</del>	<del>EUROPE</del>				
		<del>1,215,614 A1</del>	<del>6/19/2002</del>	<del>EUROPE</del>				
		<del>WO 01/55911 A1</del>	<del>8/2/2001</del>	<del>PCT</del>				
		<del>WO 02/39486 A2</del>	<del>5/16/2002</del>	<del>PCT</del>				

**OTHER DOCUMENTS**

(Including Author, Title, Date, Pertinent Pages, Etc.)

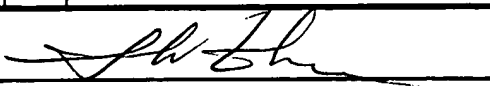
		Office Action issued by Korean Patent Office on December 23, 2004 for Corresponding Korean Patent Application No. 10-2003-0007122

EXAMINER

DATE CONSIDERED

9/21/08

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				ATTY DOCKET NO. <b>YPL-0080</b>		APPLICATION NO. <b>10/773.507</b>		
				APPLICANT(S) <b>Taejoon KWON</b>				
				FILING DATE <b>2/5/2004</b>		GROUP ART UNIT <b>1645</b>		
<b>U.S. PATENT DOCUMENTS</b>								
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>								
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<b>FOREIGN PATENT DOCUMENTS</b>								
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
		<del>WO 01/01294 A2</del>	<del>1/4/2001</del>	<del>PCT</del>				
<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>								
EXAMINER 				DATE CONSIDERED <b>9/21/08</b>				
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>								



